

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:)

Chen et al.)

Serial No.: 10/697,589)

Filed: October 30, 2003)

For: METHOD FOR MAKING)
NANOSCALE WIRES AND)
GAPS FOR SWITCHES AND)
TRANSISTORS)

Examiner: WEISS, H.

Art Unit: 2814

Confirmation No.: 8317

*Do not
enter
6/24/05*

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENTS AND REMARKS

Dear Sir:

In response to the Office Action mailed April 13, 2005, and per the Request for Continued Examination filed herewith, please consider the following remarks and enter the following amendments.

Amendments to the specification are presented on page 2 of this response. Amendments to the claims are presented beginning on page 3 of this response. Remarks begin on page 7 of this response.